

LIST OF PRIOR ART CITED BY APPLICANT  
(Filed on April 13, 2005)

Docket No. GK-0881-181 / 500814.20083

Applicant(s): Guido HERGENHAN, Christian ZIENER and Kai GAEBEL

Application No. 10/788,609

Group: 2877 2884

Filed: February 27, 2004

Examiner:

## U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub-Class	Translation	
							YES	NO
OG	AL	WO 01/49086	07/05/2001	WIPO				n/a
OG	AM	WO 02/32197	04/18/2002	WIPO				n/a
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							

## OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

OG	AV	Review of Scientific Instruments, February 2003, Vol. 74, No. 2, pages 969 – 974, Article: "Spatial characterizaion of extreme ultraviolet plasma generated by laser excitation of xenon gas targets" Sebastian KRANZUSCH, et al.
	AW	
	AX	
	AY	
	AZ	

Examiner:

Date: 02/22/06

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**LIST OF PRIOR ART CITED BY APPLICANT**  
(Filed on February 27, 2004)

Docket No. GK-OEH-181 / 500814.20083

Applicant(s): Guido HERGENHAN, Christian ZIENER and Kai GAEBEL

Application No. 10/788,609

Group: 2884

Filed: concurrently herewith -February 27, 2004

Examiner:

**U.S. PATENT DOCUMENTS**

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	AA						
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**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	CLASS	Sub-Class	Translation	
							YES	NO
OG	AL	0 186 491	06/17/1992	European				n/a
OG	AM	WO 97/40650	10/30/1997	WIPO				n/a
OG	AN	0 895 706	02/10/1999	European				n/a
OG	AO	WO 01/30122	04/26/2001	WIPO				n/a
	AP							
	AQ							
	AR							
	AS							

**OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

	AV	
	AW	
	AX	
	AY	
	AZ	

Examiner: <i>Phil Galt</i>	Date: 02/22/06
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<b>Application Number</b>	<b>10/733,609</b>
<b>Filing Date</b>	<b>December 10, 2003</b>
<b>First Named Inventor</b>	<b>Philip C. HADLEY</b>
<b>Art Unit</b>	<b>1780</b>
<b>Examiner Name</b>	<b>n/a</b>
<b>Attorney Docket Number</b>	<b>0179.0043</b>

[illegible]

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

Does not belong in this application